

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**


Applicant : Basol et al.  
App. No : 10/782,697  
Filed : February 18, 2004  
For : METHOD OF WAFER PROCESSING  
WITH EDGE SEED LAYER  
REMOVAL  
Examiner : Michael Manh Trinh  
Art Unit : 2822  
Conf. No. : 5582

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March 6, 2008

(Date)

  
Adam Gilbert, Reg. No. 59,967**RESPONSE TO OFFICE ACTION DATED DECEMBER 17, 2007****Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated December 17, 2007, the Applicants respectfully request that the Examiner reconsider the above-identified patent application in view of the following remarks.

**Listing of the Claims** begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.